

Notice of References Cited

Application/Control No.

09/975,256

Applicant(s)/Patent Under

Reexamination

RAMKUMAR ET AL.

Examiner

David L. Hogans

Art Unit

2813

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,479,349	11-2002	Oya et al.	438/261
	B	US-6,323,094	11-2001	Wu, Shye-Lin	438/303
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)

*	U	Van Zant, Peter; Microchip Fabrication A practical guide to semiconductor processing (2000); McGraw-Hill; Fourth Edition; pages 172-173.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.